

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hiroki Nakamura *et al.*
Serial No.: 10/586,400
Filed: April 20, 2007
For: VACUUM DEPOSITION METHOD AND SEALED-TYPE EVAPORATION
SOURCE APPARATUS FOR VACUUM DEPOSITION
Art Unit: 1712
Examiner: Keath T. Chen
Conf. No.: 3841
Att'y. Docket: 520514.00039

Response To Species Election Requirement

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

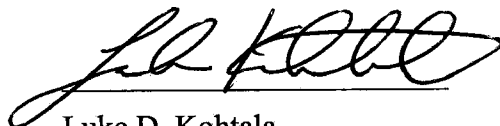
Sir:

In response to the Restriction Requirement mailed June 28, 2010 for the above application, Applicants elect Species IIA shown in Figs. 5-9 for further examination. Claims 9-11 and 13-16 read on the elected species. Claims 9, 10, and 13 are generic to all species in Group II.

No additional fees for filing this response are believed to be due. However, if such fees are due, the Commissioner is hereby authorized to charge them to deposit account no. 17-0055.

Respectfully submitted,

Date: July 28th, 2010



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